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Influence of oxygen partial pressure on the optical properties of β -Ga₂O₃₋₈ films deposited by pulsed laser deposition

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Abstract: High quality β -Ga₂O_{3-δ} films on *c*-sapphire substrates are deposited by pulsed laser deposition (PLD) under various oxygen partial pressures. The crystalline structure, chemometry and optical properties of the β -Ga₂O_{3-δ} films are investigated systematically by X-ray diffraction (XRD), far-infrared reflectance spectra, X-ray photoelectron spectroscopy (XPS) and ultraviolet-visible-near infrared (UV-vis-NIR) transmittance spectra. The XRD analysis shows that all the as-deposited films are of unique (-201) orientation. The transmittance spectra reveal that the films exhibit a high transparency above 80% in the UV-vis-NIR wavelength region above 255 nm (4.863 eV). Moreover, the optical constants and optical direct bandgap are extracted based on the transmittance spectra with Tauc-Lorentz (TL) dispersion function model and Tauc's relationship, respectively. A further step, the influence of oxygen partial pressure on optical properties is explained by theoretical calculation.

Key words: β -Ga₂O₃, pulsed laser deposition, oxygen partial pressure, optical properties

氧分压对脉冲激光沉积 β -Ga₂O₃₋₈薄膜光学性能的影响

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摘要:在不同氧分压下,用脉冲激光沉积法在c-蓝宝石衬底上制备了高质量β-Ga₂O_{3-δ}薄膜。通过X-射线衍射、远红外反射光谱、X-射线光电子能谱和紫外-可见-近红外透射光谱系统地研究了β-Ga₂O_{3-δ}薄膜的晶格结构、化学计量比和光学性质。X-射线衍射分析表明,所有沉积的薄膜以(-201)晶向方向生长。透射光谱显示薄膜在 255 nm以上的紫外-可见-近红外波段具有 80%以上的高透明度,同时在 255 nm附近有一个陡峭的吸收边。此外,利用Tauc-Lorentz (TL)色散函数模型和Tauc公式,我们提取了β-Ga₂O_{3-δ}薄膜的光学常数和光学直接带隙。更进一步,我们通过理论计算解释了氧气分压对β-Ga₂O_{3-δ}薄膜光学性质的影响。

关键 词:氧化镓;脉冲激光沉积;氧分压;光学性质

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Introduction

Gallium oxide (Ga_2O_3) has five polymorphs: α , β , γ , δ and $\varepsilon^{[1-3]}$. When heated to a certain temperature, all other phases are converted to the monoclinic β phase, which is the most stable structure^[4-5]. As an ultra wide bandgap oxide semiconductor (~ 4.9 eV), β -Ga₂O₂ exhibits better optical properties and high breakdown electrical field $(\sim 8 \times 10^6 \text{ V/cm})^{[6-8]}$. Therefore, gallium oxide has great application prospects in gas sensors, solarblind ultraviolet photodetectors, electroluminescent devices, high power devices and other electronic devices^[9-12]. In addition, β -Ga₂O₃ can be used as a window on some types of optical devices due to the high optical transparency below its optical bandgap^[1]. Gallium oxide films can be prepared by metal-organic chemical vapor deposition^[2,13], molecular beam epitaxy^[14], radio frequency sputtering^[15], atomic layer deposition^[16], solgel^[17], and pulsed laser deposition (PLD)^[18-19]. Among these methods, PLD has its unique advantages: i) it can keep the composition of deposited films and target consistent; ii) it can control the oxygen vacancies in gallium oxide film by adjusting the oxygen partial pressure; iii) it can be used to grow single crystal films at low temperature and low vacuum; iv) it has strong flexibility and a fast growth speed, which could satisfy the needs of previous research on gallium oxide films.

Deposition of gallium oxide films by PLD has been reported by other research groups. Wang et al. reported the effects of deposition temperatures on the performance of gallium oxide films for optoelectronic devices. They finally realized the β -Ga₂O₃ based solar-blind detectors with a good performance of a low dark current (10.6 pA) at 10 V and a high peak responsibility (18.23 A/W) at 255 nm^[20]. For PLD deposition of β -Ga₂O₃ films, oxygen partial pressure, deposition time, laser power and substrate types are essential for the quality of the as-deposited films besides deposition temperature^[21-23]. Under different oxygen partial pressures, oxygen vacancies at gallium oxide films will change, resulting in the variations on optical constants and bandgap. This change can be extracted from the transmission spectra in the ultravioletvisible-near infrared (UV-vis-NIR) wavelength range.

In this work, the β -Ga₂O₃ films on *c*-sapphire have been deposited by PLD under different oxygen partial pressures. It is found that the films exhibit a high transparency above 80% in the UV-vis-NIR wavelength region above 255 nm. The influences of oxygen partial pressure on optical properties such as optical constants and optical bandgap have been discussed in detail. The results are helpful to develop the application of Ga₂O₃-based photodetectors.

1 Experiments

Gallium oxide films were deposited on *c*-sapphire substrates by PLD under various oxygen partial pressures ($P_0 = 5$, 10, 20, and 40 mTorr). First, sapphire substrates were cleaned by acetone, ethanol, and deionized water for 5 mins in an ultrasonic cleaning bath before de-

position. Gallium oxide target was synthesized by gallium oxide powder with a purity of 99.9%. Then, the csapphire substrates were heated to 700 °C. A pulsed KrF laser (248 nm) with the energy density of 2.6 mJ/cm² was used at a repetition rate of 10 Hz and the deposition time was 1 h. The pressure in the vacuum chamber was less than 5×10⁻⁴ mTorr, and high purity oxygen (99.999%) was passed into the cavity as active gas. Note that the holder was rotated to deposit a uniform film. The effect of oxygen partial pressure on gallium oxide films has been systematically studied. The structural characteristics of gallium oxide films were analyzed by Xray diffraction (XRD, Bruker D8 Advance diffractometer) with a Cu K α radiation $\lambda = 1.541$ 8 Å at room temperature. The far-infrared (FIR) reflectance spectra in the wavenumber range of 50-700 cm⁻¹ were recorded by Bruker VERTEX 80V FTIR spectrometer. X-ray photoelectron spectroscopy (XPS, RBD-upgraded PHI-5000C ESCA system, PerkinElmer) with a Mg Ka radiation $(h\nu = 1 253.6 \text{ eV})$ was used to analyze the stoichiometries and valence states of elements in the as-grown $Ga_2O_{3-\delta}$ films. The UV-vis-NIR transmission spectra were measured with a double-beam ultraviolet-infrared spectrophotometer (PerkinElmer Lambda 950) in the photon wavelength range from 200 nm to 1 000 nm (1.24~6.2 eV) with a step of 2 nm. The transmission spectra were fitted by the Tauc-Lorentz model, and the absorption edge and optical constants of β -Ga₂O₃ films on *c*-sapphire substrates were obtained, which are consistent with the theoretical prediction.



Fig. 1 (a) Plane-view and (b) cross-sectional SEM images of a β -Ga₂O_{3- δ} film deposited under the oxygen partial pressure of 20 mTorr, and (c) XRD patterns of the as-grown β -Ga₂O_{3- δ} films on *c*-sapphire substrates deposited under various oxygen partial pressures from 5 to 40 mTorr, the peaks labelled by the symbol (*) come from the sapphire substrates, (d) FIR reflectance spectra of the Ga₂O_{3- δ}/*c*-sapphire samples. The dashed lines indicate the transverse optical (TO) infrared active phonon modes. Note that the curves are shifted vertically for clarity

图1 在 20mTorr 氧分压下 制备的 β -Ga₂O₃₋₆薄膜样品的(a)表面和(b)界面 SEM 图,(c) 5~40mTorr 不同氧分压下,在c-蓝宝石衬底上生长的 β -Ga₂O₃₋₆薄膜的 X-射线衍射谱,(d) β -Ga₂O₃₋₆ c-蓝宝石样品的远红外反射光谱,虚线表示横向光学(TO)红外活性声子模式,为了清晰,在y方向上对光谱进行了平移

2 Results and discussions

As an example, the plane-view and cross-sectional microstructure of the Ga₂O_{3.8} film deposited under the oxygen partial pressure of 20 mTorr are shown in Fig. 1(a) and 1(b), respectively. It suggests that the film surface is smooth and its thickness is about 200 nm. Fig. 1(c) shows the XRD patterns of gallium oxide films deposited on *c*-sapphire substrates under different oxygen partial pressure of 5, 10, 20 and 40 mTorr. It reveals that all the spectra have obvious characteristic peaks nearby 18.9, 38.4, 41.9, and 59.1°. The peak at around 41.9° originates from the c-sapphire substrate, corresponding to the (0006) plan^[24]. The peaks nearby 18.9, 38.4, and 59.1° are assigned to (-201), (-402) and (-603) planes of β -Ga₂O₃, respectively. It indicates that the polycrystalline monoclinic β -Ga₂O₃ films with high quality are grown with the (-201) preferred orientation $(\text{JCPDF No. 41-1103})^{[20]}$. Fig. 1 (d) displays the FIR reflectance spectra in the wavenumber range of 50-700 cm⁻¹. There are three obvious reflection bands, which are located at around 150, 220, and 303 cm⁻¹, respectively. According to the prediction of group theory about β - Ga_2O_3 : $\Gamma_{opt} = 10A_g(Raman) + 5B_g(Raman) + 4A_u(IR) + 8B_u(IR)^{[25-26]}$, the IR-spectra of the samples are very similar to those of monoclinic system. The reflection band of 150. 4 cm⁻¹ is the $A_{\mu}(TO_1)$ vibration mode, which is corresponding to the upward and downward movement of gallium ions. The $B_{\mu}(TO_1)$ one nearby 219.8 cm⁻¹ arises from the scissor's movement of Ga-O-Ga. The $A_{\mu}(TO_{2})$ vibration (302. 8 cm⁻¹) is related to a symmetrical Ga-O-Ga stretching^[26-27]. Note that the phonon frequencies are almost the same for the β -Ga₂O_{3.8} films deposited under various oxygen pressures, while the related intensities of B_{μ} (TO₁) and A_{μ} (TO₂) have an obvious difference. It means the Ga-O-Ga related lattice dynamics and crystalline structure are affected by the oxygen partial pressure.

The survey XPS spectra of the four gallium oxide films on *c*-sapphire substrates were measured, which have a similar feature. As an example, Fig. 2(a) shows the survey XPS of the β -Ga₂O₂₋₈ films deposited under the oxygen partial pressure of 5 mTorr. The experimental results were calibrated with the C 1s peak at 284.5 eV. The strong peaks come from Ga 3d, Ga 3p, Ga 3s, Ga 2p, Ga LMM Auger peak, O 1s, C 1s and O KLL^[28]. The appearance of the carbon peak can be ascribed to the adsorption of amorphous carbon pollutants on the film surface^[29]. However, no aluminum peaks were observed, indicating that the substrate ions do not diffuse into β -Ga₂O₃₋₈. The XPS spectra contain peaks of O, Ga, and C without other elements, which indicate that the purity of the deposited gallium oxide films is high. The fine scanning spectra and fitted results from Ga 2p and O 1s peaks are depicted in Fig. 2(b) and Fig. 2 (c), respectively. The relative atomic ratio and bonding phase of the surface region were calculated by Shirley iterative method and linear function based on the asymmetric shape analysis of Ga 2p and O 1s spectra. The Gaussian-Lorentzian mixture function is used to simulate the experimental spectra by the program XPSPEAK4.1.



Fig. 2 (a) The survey XPS spectra of β -Ga₂O₃₋₆ films deposited under the oxygen pressure of 5 mTorr, the experimental and bestfitted XPS fitting results of the (b) Ga 2p and (c) O 1s peaks for samples deposited under the various oxygen pressures of 5, 10, 20, and 40 mTorr

图 2 (a) 在 5 mTorr 氧压下沉积的 β -Ga₂O₃₋₅薄膜的光电子能 谱,(b) 在不同氧压(5,10,20和40 mTorr)下沉积的样品的Ga 2p和(c) O 1s峰的实验和最佳拟合结果

Fig. 2(b) shows that Ga 2p exhibits two sub peaks (Ga $2p_{1/2}$ and Ga $2p_{3/2}$) nearby 1145 and 1118 eV, respectively. The fitting results suggest that the peaks have a shift to high binding energy from 1144. 52 to 1144. 55 eV for Ga 2p_{1/2} and 1117. 65 to 1117. 68 eV for Ga 2p_{3/2} with increasing the oxygen pressure. Fig. 2(c) shows the XPS fitting results of the O 1s nuclear level spectra. The O 1s peak can be fitted to be composed of the Ga-O bond of Ga_2O_3 at the binding energy of 530. 37~531. 45 eV, the O-H bond nearby 531. 79~531. 87 eV and oxygen vacancies at around 530. 91~531. 11 eV. It indicates that O 1s peaks come from Ga₂O₃, oxygen vacancy and O-H, and shift to higher binding energy as the oxygen partial pressure increases. Many factors, such as charge transfer effect, electric field, hybridization and environmental charge density, could cause the shift of binding energy. Among these factors, charge transfer effect plays an important role^[30]. Finally, we obtained Ga:O ratio values of the β -Ga₂O₃₋₈ films deposited under the oxygen partial pressures of 5, 10, 20 and 40 mTorr, which are 2: 2. 614, 2:2. 658, 2:2. 670, and 2:2. 714, respectively.

In Fig. 3(a), the UV-vis-NIR transmission spectra of β -Ga₂O₃₋₈ films deposited under various oxygen partial pressures can be divided into a transparent area in the visible region and an intensely absorbing area in the ultraviolet region. The transmittance of all the films in the vis-NIR range is above 80%, indicating that the films have good optical transmittance. Moreover, there is a sharp absorption edge nearby 255 nm (4. 863 eV). According to the well-known Tauc relationship^[31]: $(\alpha E)^2 \propto (E - E_g)$, the direct optical bandgap (E_g) decreases from 4. 96 to 4. 90 eV as the oxygen partial pressure increases from 5 to 40 mTorr, as shown in Fig. 3 (b). Note that



Fig. 3 (a) Transmittance spectra of the β -Ga₂O_{3-δ}/*c*-sapphire samples deposited under the oxygen partial pressures of 5, 10, 20, and 40 mTorr, (b) the plots of $(\alpha E)^2$ as a function of photon energy for direct bandgap, the arrows indicate the optical bandgap of β -Ga₂O_{3-δ} films, (c) experimental (dotted lines) and bestfitted (solid lines) transmittance spectra of a β -Ga₂O_{3-δ} film under the oxygen partial pressure of 40 mTorr, (d) refractive index *n* and (e) extinction coefficient κ of the β -Ga₂O_{3-δ} films deposited at various oxygen partial pressures, (f) the extracted absorption edge as a function of oxygen partial pressure

图 3 (a) 在 5, 10, 20, and 40 mTorr 氧分压下沉积的 β-Ga₂O_{3-δ}/c-蓝宝石样品的透射光谱,(b) (αE)2作为直接带隙光 子能量的函数,箭头表示β-Ga₂O_{3-δ}薄膜的尖登带隙,(c) 在 40 mTorr 氧气分压下沉积的β-Ga₂O_{3-δ}薄膜的实验(虚线)和最佳拟 合(实线)透射光谱,(d) 在不同氧分压下沉积的β-Ga₂O_{3-δ}薄膜 的折射率 n和(e)消光系数 κ,(f) 提取的吸收边和氧分压的函 数关系

the trend is agreeing with that derived by the Tauc-Lorentz dispersion model (cf. Table 1).

In order to extract the fundamental optical parameters of gallium oxide films, the transmission spectra are analyzed by using a multilayer model (void/film/sapphire). The structure model was constructed under the hypothesis that the films grown on the substrates were treated as isotropic materials. Furthermore, the electron transitions between energy bands can be expressed by dispersion functions. The dielectric functions can be derived by the Tauc-Lorentz (TL) dispersion model, which originates from the standard Lorentz form for the imaginary part ε_2 of a collection of noninteracting atoms and the Tauc joint density of states. The TL model is extensively used to many amorphous and crystalline materials from transparent to strong absorption regions^[32-33]. The imaginary part of the TL dispersion function is

$$\varepsilon_{2}(E) = \begin{cases} \frac{AE_{0}C(E-E_{n})^{2}}{(E^{2}-E_{0}^{2})^{2}+C^{2}E^{2}} \cdot \frac{1}{E}, E > E_{g} \\ 0, E \leq E_{g} \end{cases}$$
(1)

The real part (ε_1) is derived from the Kramers-Kro-

nig relation:

$$\varepsilon_1(E) = \varepsilon_\infty + \frac{2}{\pi} P \int_{E_{\xi}}^{\infty} \frac{\xi E_2(\xi)}{\xi^2 - E^2} d\xi \qquad , \quad (2)$$

where A is the transition matrix element, E_o is the peak position energy, C is the broadening term, E_n is the electronic transition energy, and ε_{∞} is the high frequency dielectric constant. The appropriate value of ε_{∞} depends on the dispersion model at lower energies. So, ε_{∞} is fixed to a certain value ($\varepsilon_{\infty} = 1$) for all films in order to reduce the number of parameters and enhance the comparison between different films. For example, the experiment (dotted lines) and best-fitted (solid lines) spectra for the sample ($P_{a} = 40$ mTorr) are shown in Fig. 3(c). The optimized parameter (electronic transitions, film thickness, etc.) values of the TL model are summarized in Table1. The derived optical constants ($\tilde{n} = n + ik = \sqrt{\tilde{\varepsilon}}$ = $\sqrt{\varepsilon_1 + i\varepsilon_2}$) as a function of photon energy are shown in Fig. 3(d) and 3(e), respectively. In the visible-near ultraviolet region, the refractive index n increases with increasing photon energy and the extinction coefficient k is nearby zero due to the lower absorption. In the higher photon energy region above 4.5 eV, the refractive index n reaches a maximum at around 5.2 eV and the extinction coefficient k increases rapidly with increasing photon energy, indicating that the occurrence of interband transitions. These phenomena suggest that it can be used in the field of ultraviolet photodetect^[34-36]. In addition, the extracted thickness values of β -Ga₂O_{2-s} films are various between 124 and 202 nm, which is in accordance with the results of SEM (Fig. 1b). The absorption edge is various from 4.65 to 4.25 eV, as depicted in Fig. 3(f). It reveals that the oxygen partial pressure can affect film deposition speed and absorption edge/bandgap.

Table 1Parameter values of the Tauc-Lorentz model
for the Ga_2O_{3-6} films determined from the simu-
lation of transmittance spectra

表1	Tauc-Lorentz 模型拟合 Ga ₂ O ₃₋₆ 薄膜的透射光谱的参数
值	

Samples	P ₀ (mTorr)	А (eV)	E_0 (eV)	C (eV)	$\frac{E_n}{(eV)}$	Thickness (nm)
	_	69.94	4.65	1.93	4.65	124
#1	5	(6.43)	(0.07)	(0.08)	(0.02)	(1)
#2	10	23.91	5.39	2.11	4.59	168
#2		(3.93)	(0.07)	(0.2)	(0.05)	(3)
#2	20	61.82	4.88	2.08	4.58	202
#3		(6.60)	(0.34)	(0.27)	(0.04)	(3)
#4	40	63.78	4.75	1.96	4.25	143
#4		(6.60)	(0.46)	(0.25)	(0.06)	(5)

To further understand the mechanism of optical properties of the as-deposited β -Ga_2O_{3-\delta} films, the first-principles calculations were performed based on the density functional theory (DFT), using the projector augmented-wave method as implemented in the Vienna Ab initio Simulation Package (VASP) code^{[37-38]}. A plane-



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Fig. 4 (a) Band structure and (b) partial and total density of states (DOS) of intrinsic β -Ga₂O₃ 图 4 本征的 β -Ga₂O₃的(a)能带结构和(b)部分和总的态密度

wave basis set with a cutoff of 350 eV and a k-mesh of $5 \times$ 5×5 were adopted to sample the first Brillouin zone. The conjugate gradient scheme is used for the geometric optimization until the force on each atom is less than 0.01 eV/Å, and the total energy change is less than 10⁻⁶eV to acquire good convergence. The electronic properties of β -Ga₂O₃ are calculated using the HSE06 methods with a mixing exchange parameter of 0.25 and a screening parameter of 0. 2 Å-1. The calculated band structure and density of states (DOS) of the intrinsic β -Ga₂O₃ are plotted in Figs. 4(a) and 4(b), respectively. The bandgap of β -Ga₂O₃ in our calculation result is above 3.67 eV, and both the valence band maximum (VBM) and conduction band minimum (CBM) are situated at the Γ point. It means the intrinsic β -Ga₂O₃ is direct bandgap semiconductor, which is suitable for the application of optoelectronic devices^[39]. The band structure of β -Ga₂O₂ exhibits a very flat valence band, indicating a large hole effective mass and leading to a low hole mobility. From the partial DOS results, the CBM of the intrinsic β -Ga₂O₃ is formed mainly by Ga-3d states, in which the VBM is mainly composed by the O-2p, Ga-4p and Ga-4d states. Therefore, the variation in optical bandgap of the as-deposited β -Ga₂O₃₋₈ films originates from the VBM tuned by the oxygen partial pressure.

3 Conclusions

In conclusion, a series of monoclinic β -Ga₂O₃₋₈ films on *c*-sapphire substrates were deposited by PLD under the oxygen partial pressure range of 5 mTorr to 40 mTorr. XPS results indicate that the Ga: O ratio approaches to the ideal value (2:3) as the oxygen partial pressure increases. The influence of oxygen partial pressure on optical constants (refractive index *n* and extinction coefficient *k*), electronic transitions, and thickness of the as-deposited films were extracted by fitting transmittance spectra using the TL dispersion model. In particular, the optical bandgap is various with different partial oxygen pressures due to the change of the valence band maximum, which is mainly composed by O-2p, Ga-4p and Ga-4d states. It has been found that the optimum value of oxygen partial pressure is around 20 mTorr. This work provides comprehensive support to the β -Ga₂O₃ based opto-electronic applications.

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